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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/KR03/00599 03/26/2003 *SWL*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 10-2003-0000757 01/07/2003 *SWL*

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 38	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>John Crane</i> Initials <i>SWL</i>				

## ADDRESS

32605

## TITLE

Thin film transistor substrate and method for forming metal wire thereof

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